Docket No.: P2001,0128

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

HEIKO HOMMEN ET AL.

Filed

CONCURRENTLY HEREWITH

Title

METHOD FOR EXPOSING AT LEAST ONE OR AT LEAST TWO

SEMICONDUCTOR WAFERS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

U.S. Patent No. 5,877,861 (Ausschnitt et al.), dated March 2, 1999;

US Patent No. 5,863,680 (Kawakubo et al.), dated January 26, 1999;

US Patent No. 5,798,530 (Okumura), dated August 25, 1998;

European Patent Application EP 0 044 450 A1 (Hart), dated January 27, 1982.

Respectfully)submitted,

LAURENCE A. GREENBERG REG. NO. 29,308

Date: August 6, 2003

Lerner and Greenberg, P.A. Post Office Box 2480

Hollywood, FL 33022-2480

Tel: (954) 925-1100 Fax: (954) 925-1101

/kf

FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE				Attorney Docket No.: P2001,0128 Appl. No.:				
PATENT AND TRADEMARK OFFICE								
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant: HEIKO HOMMEN ET AL.				
(37 CFR 1.98(b))				Filing Date: August 6, 2003				
				Group Art Unit:				
			,					
EXAMINER			T		T	SUB	FILI	
INITIALS	╁	PATENT NO.	DATE	PATENTEE	CLASS	CLASS	DA	TE
	Α	5,877,861	3/2/99	Ausschnitt et al.	<u> </u>	ļ	ļ	
	В	5,863,680	1/26/99	Kawakubo et al.				
	С	5,798,530	8/25/98	Okumura				
	D							
	E							
	F							
	G		 					
	H			:				
	1							
· · · · · · · · · · · · · · · · · · ·								
FOREIGN PATENT DOCUMENT								
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRAI YES	
	J	0 044 450 A1	1/27/82	Europe				
	K							
	1_							
	М							
	N							
								
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)								
								_
EXAMINER		1	DATE CONSIDERED					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include								
copy of this form with next communication to applicant.								